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Bib Data Sheet

CONFIRMATION NO. 2689

SERIAL NUMBER 10/616,823	FILING DATE 07/10/2003 RULE	CLASS 438	GROUP ART UNIT 2827	ATTORNEY DOCKET NO. CU-3284 RJS
APPLICANTS Jong Hwan Kim, Kyoungki-do, KOREA, REPUBLIC OF;				
** CONTINUING DATA ***** (None) LT				
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2002-82172 12/21/2002 LT				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/08/2003				
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Examiner's Signature	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 8 INDEPENDENT CLAIMS 1
ADDRESS 26530 LADAS & PARRY 224 SOUTH MICHIGAN AVENUE, SUITE 1200 CHICAGO, IL 60604				
TITLE Method for forming bit lines of semiconductor device				
FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input checked="" type="checkbox"/> 1.18 Fees (Issue)		